06-10-05.

Application No. 10/602,361

ITWA

Customer No. 01933

Attorney Docket No. <u>03378/LH</u>

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant(s): Junichi KITAGAWA

Serial No. : 10/602,361

Filed : June 23, 2003

For : LASER SCANNING MICROSCOPE,

SEMICONDUCTOR LASER LIGHT
SOURCE UNIT, SCANNING UNIT FOR

A LASER SCANNING MICROSCOPE,

AND METHOD OF CONNECTING

SEMICONDUCTOR LIGHT SOURCE TO

SCANNING MICROSCOPE

Art Unit : 2878

Examiner : Faye S. Polyzos

**AMENDMENT** 

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

This is responsive to the Office Action mailed

April 11, 2005, the term for response to which is extended

by one month by Petition filed concurrently herewith to

August 11, 2005.

Amendments to the Drawings are described on page 2 of this paper.

Amendments to the Claims are set forth in the listing of claims which begins on page 3 of this paper. Claims 1-22 are canceled, and claims 23-36 are added.

Remarks begin on page 8 of this paper.

Express Mail Mailing Label

No.: EV 721636193 US

Date of Deposit: August 9, 2005

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner for Patents. P.O. Box 1450

Alexandria VA 22313-1450

Nalini P. Sahadeo

In the event that this Paper is late filed. and the necessary petition for extension of time is not filed concurrently herewith. please consider this as a Petition for the requisite extension of time. and to the extent not tendered by any form PTO-2038 which may be attached hereto. authorization to charge the extension fee. or any other fee required in connection with this Paper to Account No. 06-1378.